

Increase performance and wafer throughput with a dual arm wafer handling system. Combined with Jabil's robust software and motion control systems, our automated wafer handling systems are designed and built to meet your exact specifications.

## DUAL ARM WAFER HANDLING SYSTEM

### BENEFITS

#### ✓ FASTER CYCLE TIMES

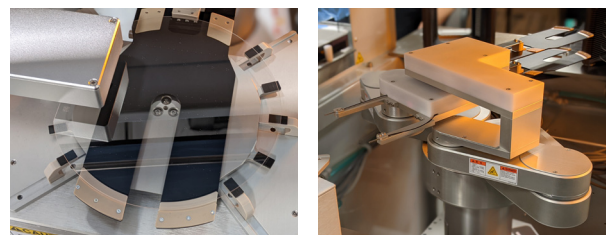
Achieve faster cycle times by maximizing robot movements within smaller spaces.

#### ✓ INCREASE THROUGHPUT

A dual arm robot configuration provides the added flexibility needed to increase wafer production and yield.

#### ✓ CLEAN ROOM READY

ISO Class 2 classification ensures your wafer handling system is production floor ready



**Supported Wafer Sizes:** Up to 300mm

**Supported Wafer Types:** Glass, Thin, Thick, Warped

**Available Gripping Methods:** Edge Grip, Vacuum

#### About Jabil Precision Automation Solutions

Jabil delivers high-performance, industry trusted automated wafer handling solutions for some of the world's leading semiconductor manufacturers and OEM process tool makers around the world.